Docket No. 3449-0921PUS1

Art Unit: 1792

LISTING OF THE CLAIMS

Please amend the claims as follows:

1. (Currently Amended) A vacuum deposition apparatus comprising:

a susceptor for heating a glass substrate, a portion of the susceptor providing an area

usedall four edges of the susceptor acting as a sliding portion on which to slide the glass

substrate to a stopped position by stopping pins placed on the sliding portion;

lift pins for supporting the glass substrate;

a support bar for supporting the susceptor and raising the susceptor with the lift pins such

that the glass substrate is supported by the lift pins and the robot arm can be withdrawn from

underneath the glass substrate;

a robot arm for transferring the glass substrate onto to a position over the susceptor-and

returning the glass substrate from the susceptor, wherein the robot arm supports a portion of the

glass substrate with a non-supported edge portion freely hanging over the robot arm such that as

the robot arm moves in a forward direction to transfer the glass substrate onto the susceptor, the

non-supported edge portion of the glass substrate slides on the sliding portion of the susceptor

and is stopped by at least one stopping pin located at the stopping position; and

a support bar for 1) supporting the susceptor and raising the susceptor with the lift pins

extended when the robot arm transfers the glass substrate to the position over the susceptor such

that the glass substrate is raised off of the robot arm and is supported by the lift pins and the

robot arm can be withdrawn from underneath the glass substrate, and for 2) lowering the

susceptor while the lift pins are withdrawn from being extended such that the edges of the glass

subtrate slide along sliding portion of the susceptor until being stopped by the stopping pins at

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which point the glass substrate is substantially parallel with the susceptor;

wherein the susceptor includes a groove formed in said all four edges of said sliding portion of the susceptor at a location of the at least one stopping pins for receiving material resulting from the sliding of the glass substrate on the sliding portion of the susceptor, and

wherein a length of said sliding portion, measured from said groove, is about 10 mm, wherein the susceptor comprises:

a first planar portion; and

a second planar portion vertically above the first planar portion and horizontally contiguous with the first planar portion such that the first and second planar portions of the susceptor form a stepped shape,

wherein the groove is formed only in the second planar portion, and

wherein the glass substrate slides on the second planar portion such that the groove receives scrapped off material resulting from the sliding of the glass substrate on the second planar portion of the susceptor.

2-3. (Canceled)

4. (Previously Presented) The vacuum deposition apparatus according to claim 1, wherein the susceptor is made of a quartz material.

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5. (Previously Presented) The vacuum deposition apparatus according to claim 1, wherein the groove has a polygonal configuration.

- 6. (Previously Presented) The vacuum deposition apparatus according to claim 1, wherein a bottom face of the groove has a curved configuration.
- 7. (Previously Presented) The vacuum deposition apparatus according to claim 1, wherein a bottom face of the groove includes an incline plane and a perpendicular plane.
- 8. (Previously Presented) The vacuum deposition apparatus according to claim 1, wherein the groove has a V-shaped configuration.
 - 9. (Canceled)
- 10. (Previously Presented) The vacuum deposition apparatus according to claim 4, wherein the susceptor is in direct contact with the glass substrate when the glass substrate is heated.

11-15. (Canceled).

16. (Previously Presented) The vacuum deposition apparatus according to claim 1, wherein the susceptor is rectangular.

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17. (New) The vacuum deposition apparatus according to claim 1, wherein the stopping pins are formed within the groove such that the glass substrate slides over part of the groove before being stopped by the stopping pin and causes the material to be dumped into the groove.